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PATENT

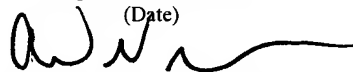
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Sherman
Appl. No. : 10/692,243
Filed : October 22, 2003
For : SEQUENTIAL CHEMICAL
VAPOR DEPOSITION
Examiner : Eric B. Fuller
Group Art Unit : 1762

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

September 26, 2005

(Date)


Andrew N. Merickel, Reg. No. 53,317

RESPONSE TO OFFICE ACTION

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on June 16, 2005 and is accompanied by a request for a one-month extension of time. Consideration of the following remarks is respectfully requested.

Remarks/Arguments begin on page 2 of this paper.

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